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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	Translation YES	NO
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/SMH/ Kiyotaka MIURA et al., "Formation of Photo-induced Structures in Glasses with Femtosecond Laser," Dai 42 Kai Proceedings of Laser Materials Processing Conference, 1997, pp. 105-111.

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/SMH/ Tomokazu SANO et al., "Ultrashort Pulse Laser Microprocessing of Silicon," Short Pulse and Short Wavelength Laser Precision Microprocessing of Electric Materials (first report), 2000, pp. 72-73.

/SMH/ Shuji TAKAOKA, "Principle and Characteristics of Stealth Dicing Technology Optimal for Dicing of Ultrathin Semiconductor Wafer," Denshi Zairyo, September 1, 2002, pp. 17-21.

Examiner /Samuel M. Heinrich/ (10/15/2009) Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.